

Patent
10007744-1RESPONSE UNDER 37 CFR SECTION 1.116
EXPEDITED PROCEDURE – GROUP ART UNIT 1765

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Simon Dodd

Application No.: 09/932,055

Filed: August 16, 2001

For: THERMAL INKJET PRINthead
PROCESSING WITH SILICON
ETCHING

Examiner: Lynette T. Umez-Eronini

Group Art Unit: 1765

Confirmation No.: 5019

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MAR 09 2006RESPONSE TO THE FINAL OFFICE ACTIONMAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the final Office Action of January 11, 2006, please amend the above-identified application for patent as follows.

Enter Amendment,

L.T.U-E,

3/23/2006

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